



RCE/1763  
702

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

February 6, 2003

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

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Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired November 6, 2003, an extension of time for a period of three months is hereby requested. (Payment of \$110 for a one month extension was already made.)

Attached hereto is our Check No. 138756 in the amount of \$820 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00)

Extension fee for response within second month pursuant to §1.136(a) (\$410.00)

Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Director is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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Registration No. 27,075

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Registration No. 52,304

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